

Notice of References Cited	Application/Control No. 10/699,433	Applicant(s)/Patent Under Reexamination STEIGERWALD ET AL.	
	Examiner Andy Huynh	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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